Electronic Acknowledgement Receipt				
EFS ID:	4095753			
Application Number:	09546174			
International Application Number:				
Confirmation Number:	4793			
Title of Invention:	HIGH DENSITY PLASMA CHEMICAL VAPOR DEPOSITION PROCESS			
First Named Inventor/Applicant Name:	Chih-Chien Liu			
Customer Number:	26021			
Filer:	William H. Wright/Lillian Rodriguez			
Filer Authorized By:	William H. Wright			
Attorney Docket Number:	JIA 462C1			
Receipt Date:	10-OCT-2008			
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Time Stamp:	14:52:50			
Application Type:	Utility under 35 USC 111(a)			

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Submitted with Payment	no
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## File Listing:

Document Number	Document Description	File Name	File Size(Bytes)/ Message Digest	Multi Part /.zip	Pages (if appl.)
1	Appeal Brief Filed	20952-4002-AppealBrief.pdf	1359565	no	42
, Appealant med	2032 TOOL Appealonempal	7137bcbefadaf555a4c8cb1e195fc38394a0 cb3		"-	
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## New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

### National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filling Receipt in due course.

#### New International Application Filed with the USPTO as a Receiving Office

If a new international application is being filed and the international application includes the necessary components for an international filing date (see PCT Article 11 and MPEP 1810), a Notification of the International Application Number and of the International Filing Date (Form PCT/RD/105) will be issued in due course, subject to prescriptions concerning national security, and the date shown on this Acknowledgement Receipt will establish the international filing date of the application.